



IN THE UNITED STATES
PATENT AND TRADEMARK OFFICE

PATENT APPLICATION

Applicant(s): **Wu et al.**

Case: **4658**

Serial No.: **09/583,512**

Filed: **May 31, 2000**

Title: **SYSTEM AND METHOD FOR CHEMICAL MECHANICAL PLANARIZATION**

THE COMMISSIONER OF PATENTS AND TRADEMARKS
Washington, D. C. 20231

S I R:

Disclosure Statement under 37 CFR 1.56 and 1.98

Pursuant to 37 CFR 1.56, the documents (copies enclosed) listed on form PTO-1449, submitted herewith, are disclosed. Under rule 37 C.F.R. 1.98(a), the applicants submit that no specific comments are necessary for any of the cited English language publications having an enclosed English language translation or abstract.

Respectfully submitted,

June 17, 2000
Date

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CERTIFICATE OF MAILING under 37 C.F.R. 1.8(a)

I hereby certify that this correspondence is being deposited on June 19, 2000 with the United States Postal Service as first class mail, with sufficient postage, in an envelope addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.

Michael Cerni

Signature

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